

PATENT



Docket No. 1232-4610

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): K. YANAGITA, et al.

Serial No.: 10/081,068 Group Art Unit: 2812

Filed: February 21, 2002 Examiner: TBA

For: COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR, BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR, TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE MANUFACTURING METHOD

STATUS INQUIRY

Mail Stop _____
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

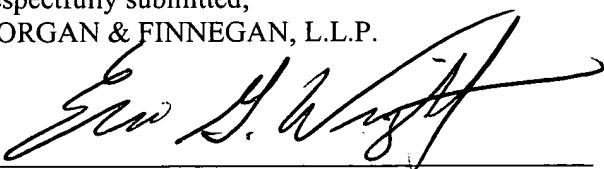
As per the above-captioned information, on February 21, 2002 applicant filed the above-identified patent application which was assigned U.S. Patent Application Serial No. 10/081,068. As of the date of this letter, Applicant has not received an Official Action from the Patent and Trademark Office.

Accordingly, the Office is respectfully requested to advise applicant about the status of this application. The Office is urged to telephone undersigned at the number noted below if any further information is needed.

Respectfully submitted,
MORGAN & FINNEGAN, L.L.P.

Dated: June 22, 2004

By:


Eric G. Wright

Registration No. 48,045

Correspondence Address:

MORGAN & FINNEGAN, L.L.P.
345 Park Avenue
New York, NY 10154-0053
(212) 758-4800 Telephone
(212) 751-6849 Facsimile



MORGAN & FINNEGAN, LLP
1775 EYE STREET, N.W., SUITE 400
WASHINGTON, D.C., 20006-2401

WRITER'S DIRECT DIAL
(202) 857-8012
ewright@morganfinnegan.com

TELEPHONE: (202) 857-7887
FACSIMILE: (202) 857-7929
www.morganfinnegan.com

NEW YORK OFFICE
345 PARK AVENUE
NEW YORK, NEW YORK, 10154-0053
TELEPHONE: (212) 758-4800
FACSIMILE: (212) 751-6849

June 22, 2004

Mr. Yasunori Ohtsuka
Ohtsuka Patent Office
7th F., Shuwa Kioicho Park Bldg.
3-6, Kioicho, Chiyoda-ku
Tokyo 102-0094, Japan

Re: U.S. Patent Application Serial No. 10/081,068
For: *COMPOSITE MEMBER AND SEPARATING METHOD THEREFOR,
BONDED SUBSTRATE STACK AND SEPARATING METHOD THEREFOR,
TRANSFER METHOD FOR TRANSFER LAYER, AND SOI SUBSTRATE
MANUFACTURING METHOD*
Your Ref: CFM 1814US/P200-0004US
Our Ref: 1232-4610US1

Dear Mr. Ohtsuka:

We filed a Status Inquiry in the United States Patent & Trademark Office today.
Copies of the filing papers are enclosed for your records.

We will keep you apprised of further development in this matter as they occur. If you have any questions, or comments, please do not hesitate to contact us.

Sincerely,

Eric G. Wright

EGW/crp

Enclosures
cc: Joseph A. Calvaruso